

 <p>OFFICE OF ART CITED BY APPLICANT (PTO-1449)</p>	ATTY. DOCKET NO. DPO-0010	APPLN. SERIAL NO. 10/714,926
	APPLICANT(S) Hae Pyoung LEE	
	FILING DATE November 18, 2003	GROUP 2621

**U.S. PATENT DOCUMENTS**

EXAMINER'S INITIALS	*PATENT NO.	*ISSUE DATE	*INVENTOR NAME	CLASS	SUBCLASS	FILING DATE

**U.S. PATENT APPLICATION PUBLICATIONS**

EXAMINER'S INITIALS	*PATENT APPLN. PUB. NO.	*PUB. DATE	*APPLICANT	CLASS	SUBCLASS

**U.S. PATENT APPLICATIONS**

EXAMINER'S INITIALS	*APPLN. NO.	*FILING DATE	*INVENTOR	CLASS	SUBCLASS

**FOREIGN PATENT DOCUMENTS**

EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						Yes	No
AT	JP 2000-059857	02/25/2000	Japan (English Abstract and Japanese Full Text)			X	

**OTHER ART (Including Author, Title, Date, Pertinent Pages, Publisher, Place of Publication, Etc.)**

	Copy of Japanese Office Action dated April 19, 2006.

EXAMINER /Andrew Tank/ (02/15/2007)	DATE CONSIDERED 02/15/2007
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.  
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